

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s) : Franz LAERMER et al.
Serial No. : 10/524,610
Filed : August 11, 2005
For : LAYER SYSTEM HAVING A SILICON LAYER AND A
PASSIVATION LAYER, METHOD FOR CREATING A
PASSIVATION LAYER ON A SILICON LAYER AND ITS
USE
Examiner : Hoang Ho
Art Unit : 2818
Confirmation No. : 9981

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

I hereby certify that this correspondence is being electronically transmitted to the United States Patent and Trademark Office via the Office electronic filing system on **May 22, 2009**.

Signature: /Wendy Espinal/
Wendy Espinal

**AMENDMENT TRANSMITTAL AND REQUEST FOR EXTENSION OF TIME
PURSUANT TO 37 C.F.R. §1.136(a)**

S I R:

Transmitted herewith for filing in the above-identified patent application is an Amendment in response to the Office Action of January 22, 2009.

Applicants respectfully petition for **one-month extension of time** to respond to the Office Action of January 22, 2009, for which a three-month response period expired on April 22, 2009. The extended period for response expires on May 22, 2009.

The **\$130.00** fee is **being paid by credit card**.

The Commissioner is also authorized to charge payment of any additional fees or to credit any overpayment, to the Deposit Account of Kenyon & Kenyon LLP, Deposit Account No. **11-0600**.

Respectfully submitted,

Dated: May 22, 2009

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